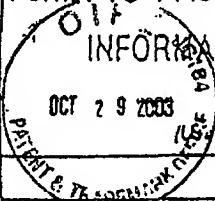


Form PTO-1449



# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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Chia-Ta Hsieh et al.

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## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
RB	6159801	12/12/00	Hsieh et al.	438	259	4/26/99
RB	5780341	7/14/98	Ogura	438	259	12/6/96
RB	6037221	3/14/00	Lee et al.	438	257	2/3/97
RB	5527727	6/18/96	Kim	437	43	9/26/95
RB	6124609	9/26/00	Hsieh et al.	257	315	11/15/99
RB	6017795	1/25/00	Hsieh et al.	438	262	5/6/98

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
					YES NO

## OTHER DOCUMENTS (Including Author, Title, Date, Portraits Pages, Etc.)


EXAMINER

Richard A. R.

DATE CONSIDERED

11/12/04

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